03500.015730.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: P. Macchiarolo
TAKASHI IWAKI ET AL.	; ;	Group Art Unit: 2875
Appln. No.: 09/941,782)	1
Filed: August 30, 2001)	
For: ELECTRON-EMITTING DEVICE, ELECTRON SOURCE AND METHOD FOR MANUFACTURING IMAGE- FORMING APPARATUS) :) :	July 10, 2003
Mail Stop DD Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. application:

APPLICATION NO.

FILING DATE

GROUP ART UNIT

10/370,662

2/24/03

1762

A copy of the cited application is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2).

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Frank A. DeLucia

Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

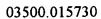
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FORM PTO 14		•		ATTY DOCKET NO. 03500.015730	APPLEATING	09/9	41,782
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		TAKASHI IWAKI ET AL. SP 2 4 7003					
	(056	Several Sheets if necess	aly)	FILING DATE AUGUST 30, 2001	G	2875	
				U.S. PATENT DOCUMENTS	77.10		
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0117670	8/2002	Horiguchi et al.	257	59	
					1		
			<u> </u>	FOREIGN PATENT DOCUMENTS			
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	EP	1 184 886 A1	3/2002	EPO	H01J	9/02	
	JP	11-120901	4/1999	Japan	H01J	9/02	Abstract
		Akiyoshi Baba e Applied Physics pp. L261-L263.		MENT(S) (Including Author, Tate, Date, Pertinent Pages, Etc.) ion from an Ion-Beam-Modified Polyimide rd Japanese Journal of Applied Physics,	e Film," Jaj Tokyo, JP,	oanese Jou Vol. 38 (199	rnal of 9), NR. 3A

XAMINER; Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw fine through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

	Sheet	1	of	1
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
••	:	Examiner: P. Macchiarolo
TAKASHI IWAKI ET AL.)	
	:	Group Art Unit: 2875
Application No.: 09/941,782)	
	:	Confirmation No.: 7656
Filed: August 30, 2001)	
_	:	
For: ELECTRON-EMITTING DEVICE,)	
ELECTRON SOURCE AND	:	
METHOD FOR MANUFACTURING)	
IMAGE-FORMING APPARATUS	:	September 23, 2003
Mail Stop Issue Fee		
Commissioner for Patents		
P.O. Box 1450		

REQUEST FOR CONSIDERATION OF PREVIOUSLY CITED ART

Sir:

Alexandria, VA 22313-1450

Applicants have received a Notice of Allowance in the above-identified application. The Examiner is sincerely thanked for allowing the application. However, Applicants have not yet received confirmation that the Information Disclosure Statement filed on July 11, 2003 has been considered in this application. A copy of the Information Disclosure Statement and a copy of the accompanying Form PTO-1449 are enclosed, as is a copy of the return receipt postcard stamped to confirm receipt of those papers by the Patent and Trademark Office.

Applicants respectfully request that the Examiner consider and make of record the art cited in the mentioned Information Disclosure Statement, and issue an initialed copy of the Form PTO-1449 as confirmation thereof.

If the Examiner requires additional copies of the art cited in the Information

Disclosure Statement, he is respectfully requested to telephone the undersigned.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Attorney for Applicant

Registration No. 4/1/16

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801

Facsimile: (212) 218-2200

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	Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	Date
FCHS-D-00	Kindly acknowledge receipt of the accompanying: Response to Official Action. Check for \$	priority applications deliverer. By Hand
	Atty. FAD/YT/bcg Due Date N/D/	T DA LIGHTO